



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 28, 2026

IGI Report Number

LG825646900

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL POLYGON STEP CUT

Measurements

10.62 X 5.45 X 3.18 MM

GRADING RESULTS

Carat Weight

1.46 CARAT

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

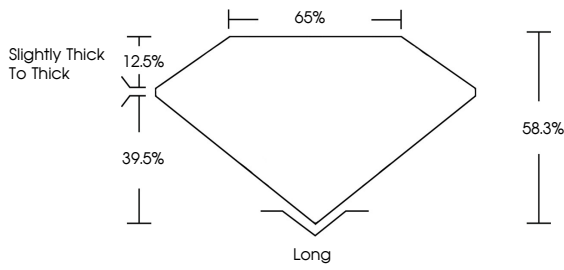
Inscription(s)

 LG825646900

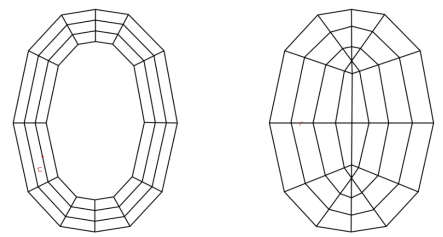
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



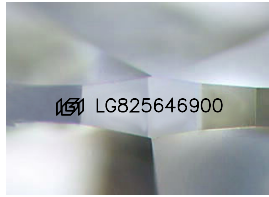
CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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Carat Weight

1.46 CARAT

Color Grade

E

Clarity Grade

VS 1

Depth

58.3%

Table

65%

Girdle

Slightly Thick To Thick

Culet

Long

Polish

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Symmetry

VERY GOOD

Fluorescence

NONE

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